

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s) : Franz LAERMER
Serial No. : 10/519,724
Filed : December 28, 2004
For : DEVICE AND METHOD FOR THE PRODUCTION OF CHLORINE TRIFLUORIDE AND SYSTEM FOR ETCHING SEMICONDUCTOR SUBSTRATES USING THIS DEVICE
Examiner : Rakesh Dhingra
Art Unit : 1792
Confirmation No. : 5180

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

I hereby certify that this correspondence is being electronically transmitted to the United States Patent and Trademark Office via the Office electronic filing system on August 10, 2009.

Signature: /Elizabeth Tretter/
Elizabeth Tretter

AMENDMENT

SIR:

In response to the Office Action of February 10, 2009, (the three-month response date for which is May 10, 2009), kindly amend the above-captioned application without prejudice as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.

Applicants respectfully request a three month extension of time in which to file this response and provide payment of the required fee in the accompanying transmittal.